



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Re the application of
HORNING et al.

Serial Number:
09/873,931

Filed: June 4, 2001

For:
APPLICATIONS OF A
STRAIN-COMPENSATED
HEAVILY DOPED ETCH STOP
FOR SILICON STRUCTURE
FORMATION

Group Art Unit:
2814

Examiner:
Steven H. Rao

Docket No. H25542US

To the Commissioner of Patents and Trademarks:

Sir:

AMENDMENT

Please enter the following amendments as part of the Request for Continued Examination filed concurrently herewith. The application is currently under Final Rejection mailed July 8, 2005, and a one (1) month extension is requested herewith. Also enclosed is PTO-2038 (02-2003) for the \$790.00 RCE fee and \$120.00 for the extension of one month time for response, in the total amount of \$910.00. Entry of the amendment and extension is respectfully requested.